



APR/IFW

P/29-1647

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Eiji HASEGAWA

Date: April 10, 2006

Serial No.: 10/768,611

Group Art Unit: 2823

Filed: January 29, 2004

Examiner: Fernando L. TOLEDO

For: SEMICONDUCTOR DEVICE WITH NITROGEN IN OXIDE FILM ON
SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURING
THE SAME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE AFTER FINAL REJECTION
REQUEST FOR RECONSIDERATION

Sir:

This is a response to the Office Action mailed January 10, 2006 in the above-identified application. Reconsideration of the application is respectfully requested.

FEE CALCULATION

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

CONTINGENT EXTENSION REQUEST

If this communication is filed after the shortened statutory time period had elapsed and no separate Petition is enclosed, the Commissioner of Patents and Trademarks is petitioned, under 37 C.F.R. § 1.136(a), to extend the time for filing a response to the outstanding Office Action by the number of months which will avoid abandonment under 37 C.F.R. § 1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.